
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Wu et al.

Attorney Docket No.:
NOVLP091/NVLS-2889

Application No.: 10/820,525

Examiner: Maldonado, Julio J.

Filed: April 7, 2004

Group: 2823

Title: METHODS FOR PRODUCING LOW-K
CDO FILMS WITH LOW RESIDUAL
STRESS

Confirmation No: 8337

CERTIFICATE OF EFS-WEB TRANSMISSION

I hereby certify that this correspondence is being transmitted electronically through EFS-WEB to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on March 4, 2008.

Signed: _____/Tara Hayden/
Tara Hayden

AMENDMENT C

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action dated October 4, 2007 in the above-identified application, please amend the application as follows:

Amendments to the Specification are shown on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims that begins on page 3 of this paper.

Amendments to the Drawings begin on page 9 of this paper and include attached replacement sheets.

Remarks/Arguments are on page 10 of this paper.

A **Declaration under 37 CFR 1.131** of co-inventor Qingguo Wu, with attached Exhibits A-F accompanies this paper.